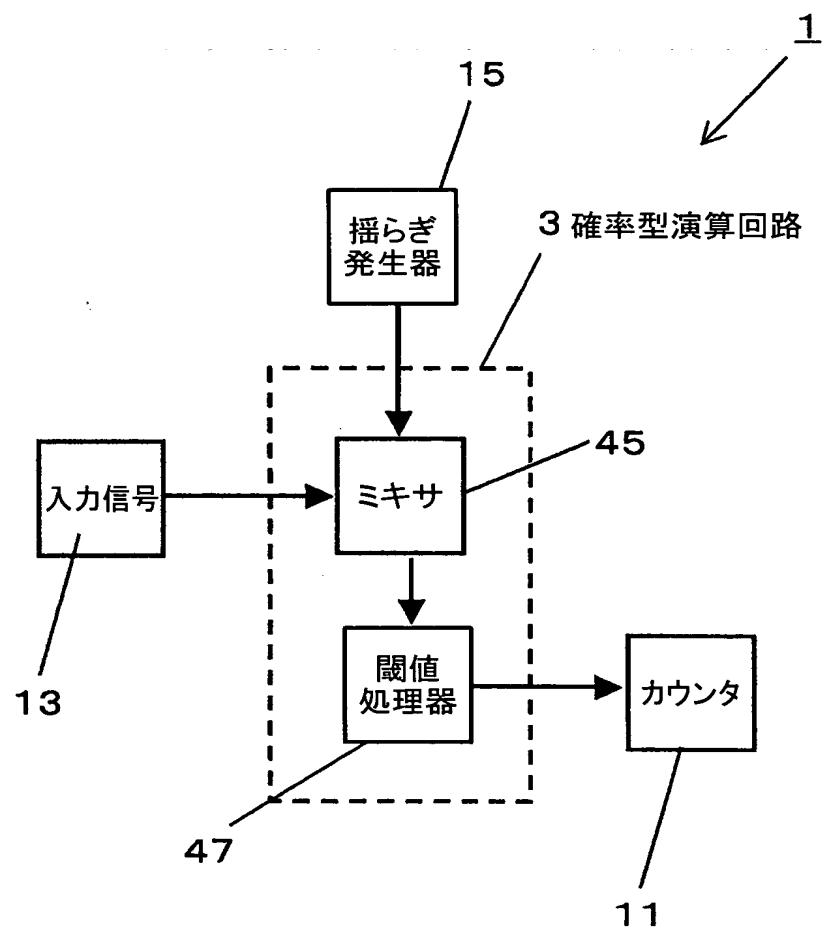
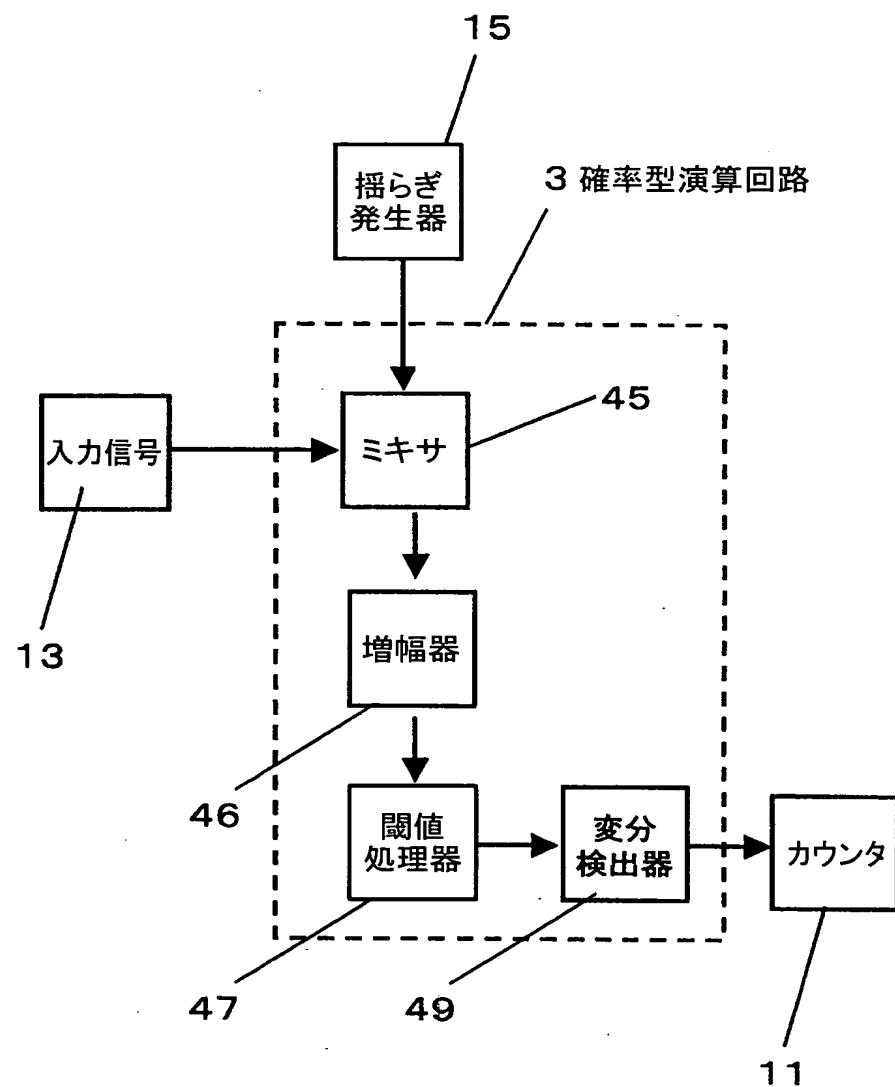


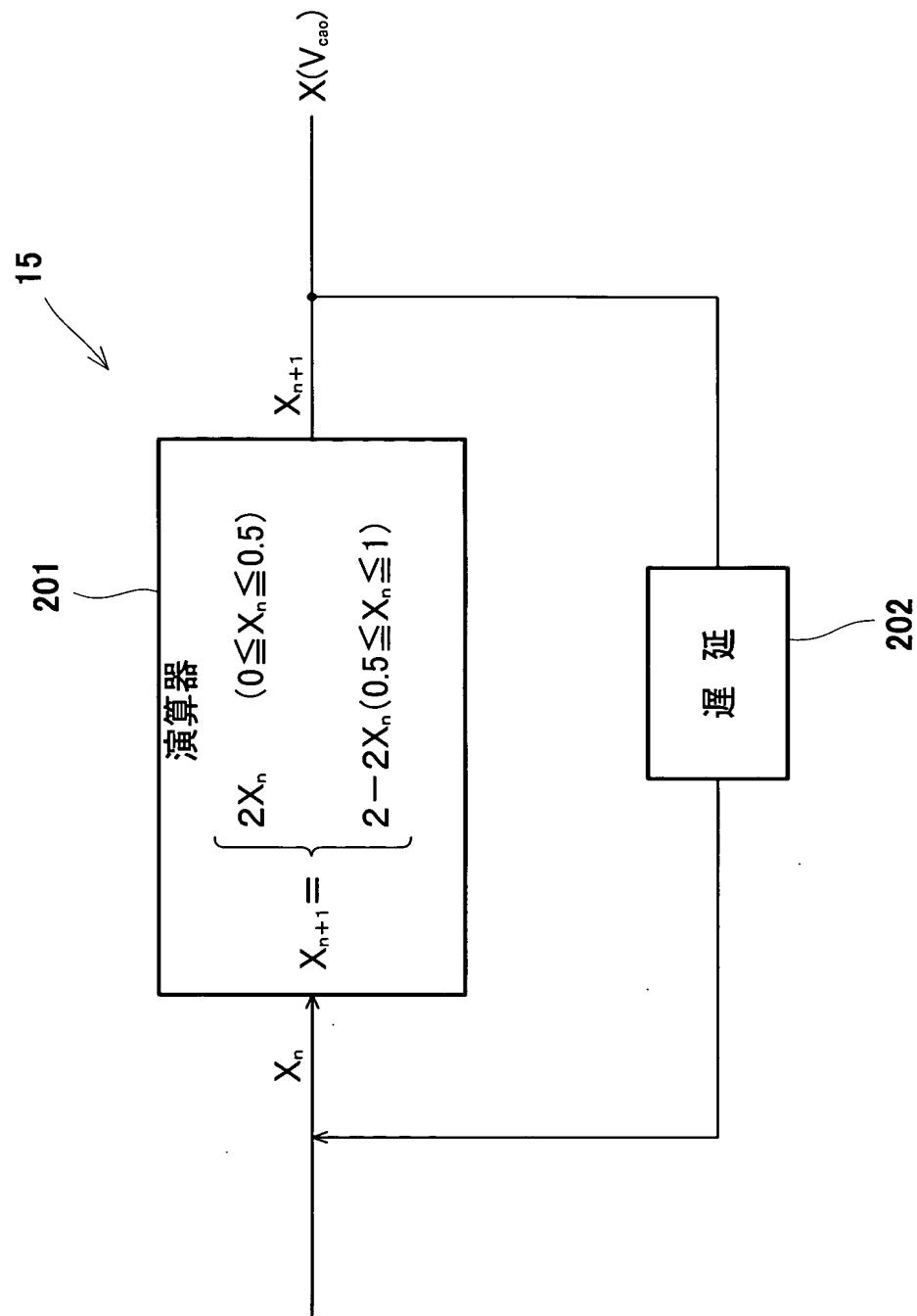
第1図



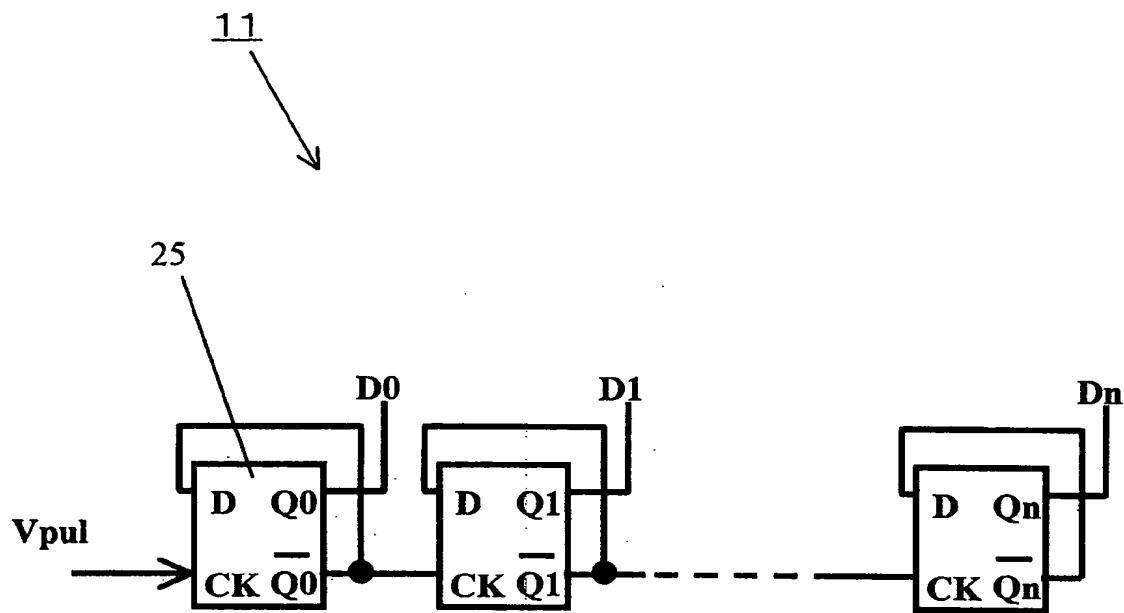
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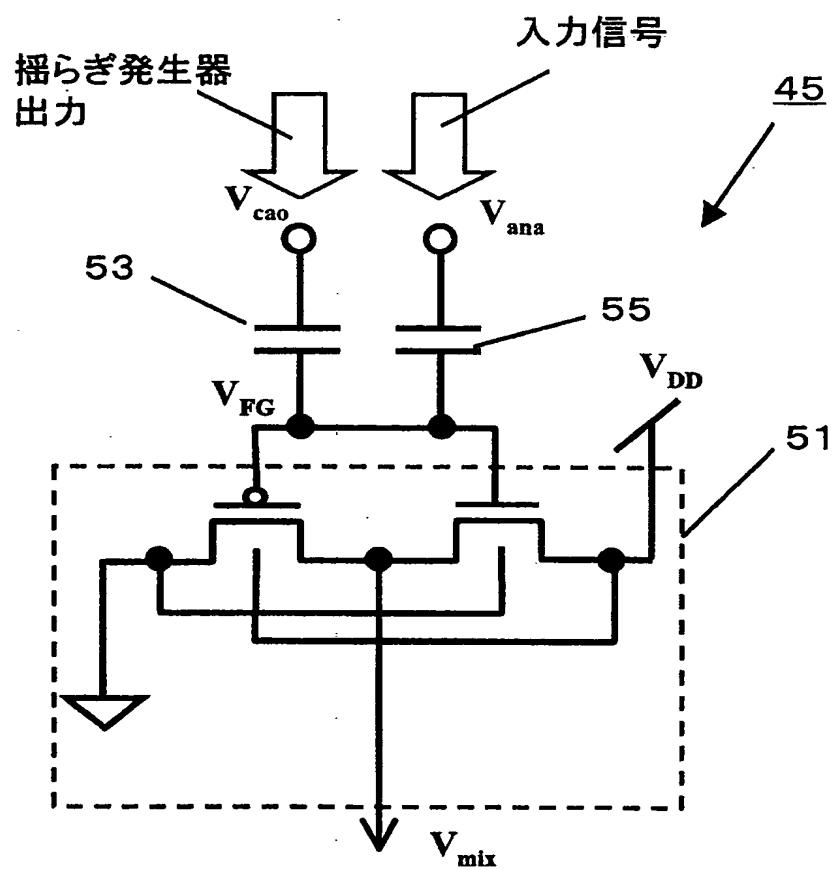
第3図



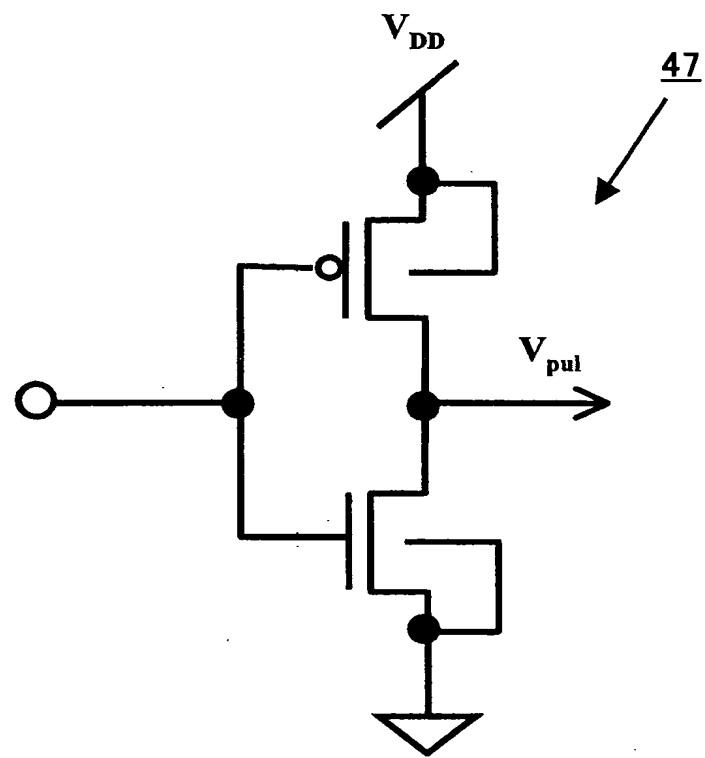
第4図



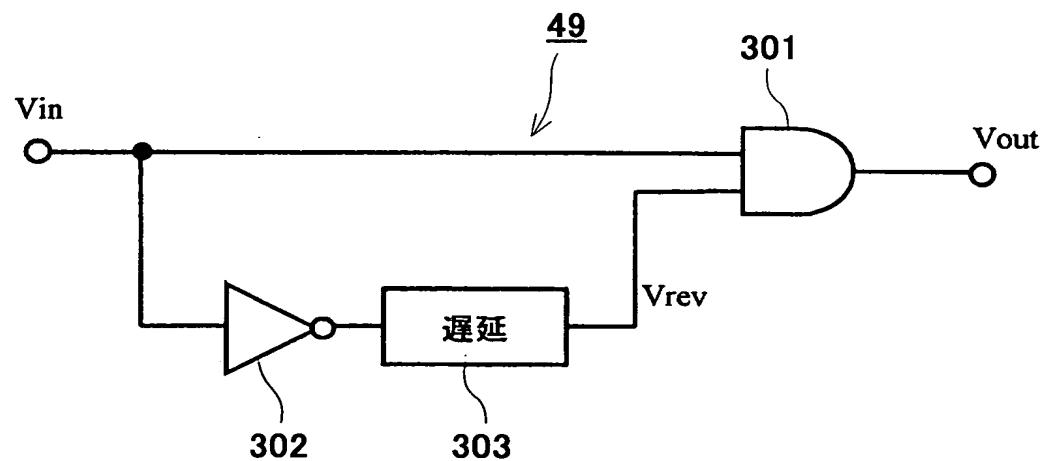
第5図



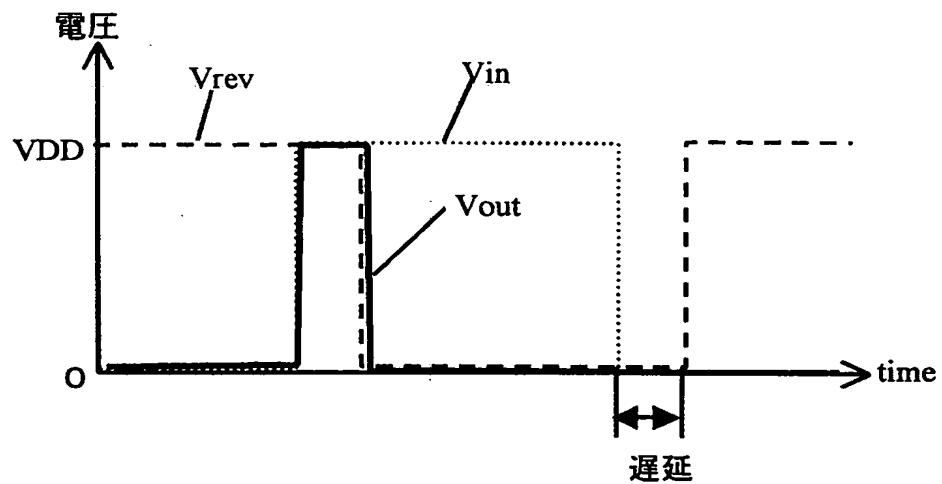
第 6 図



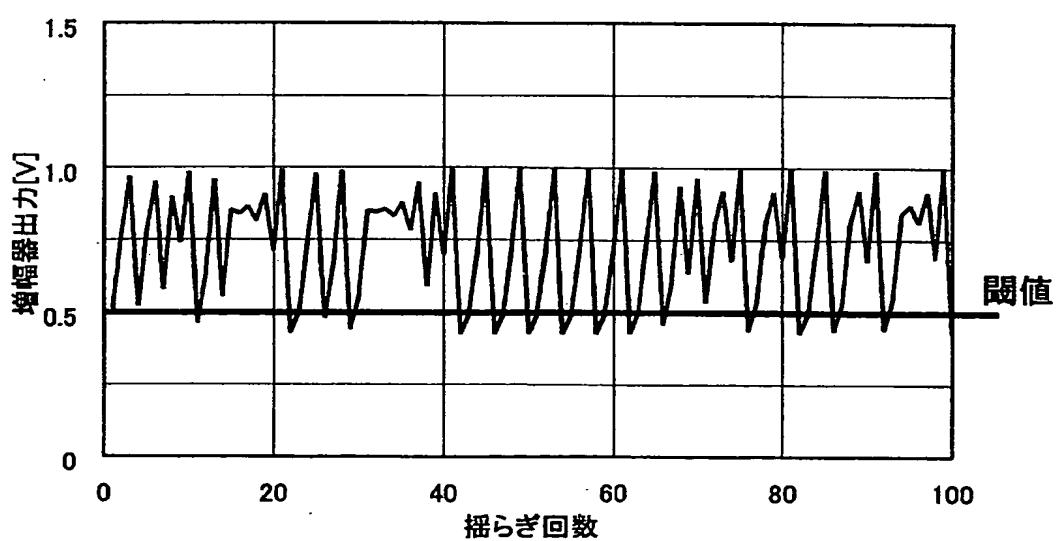
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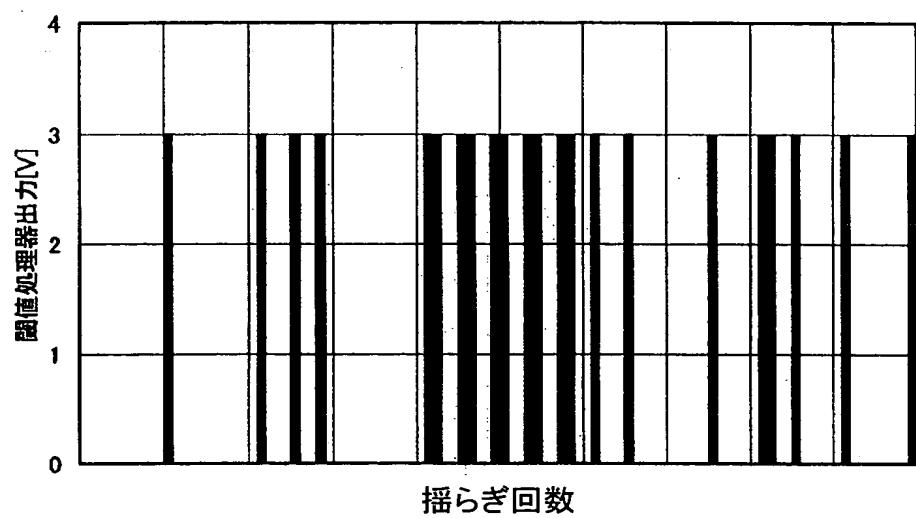
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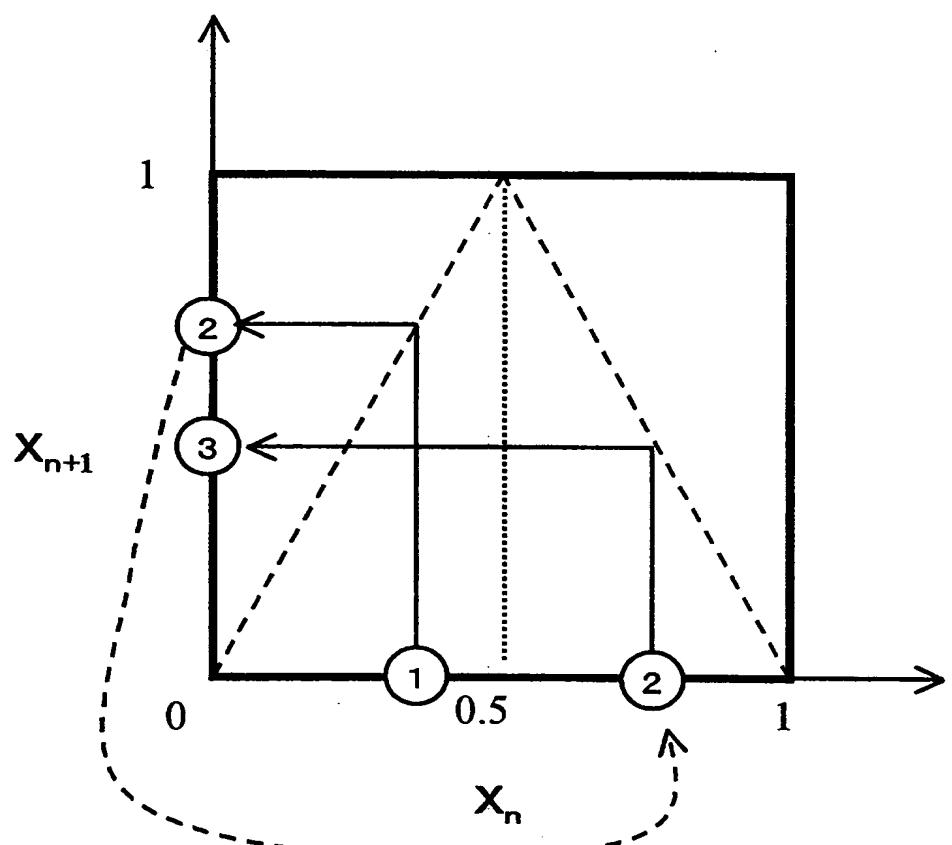
第 9 図



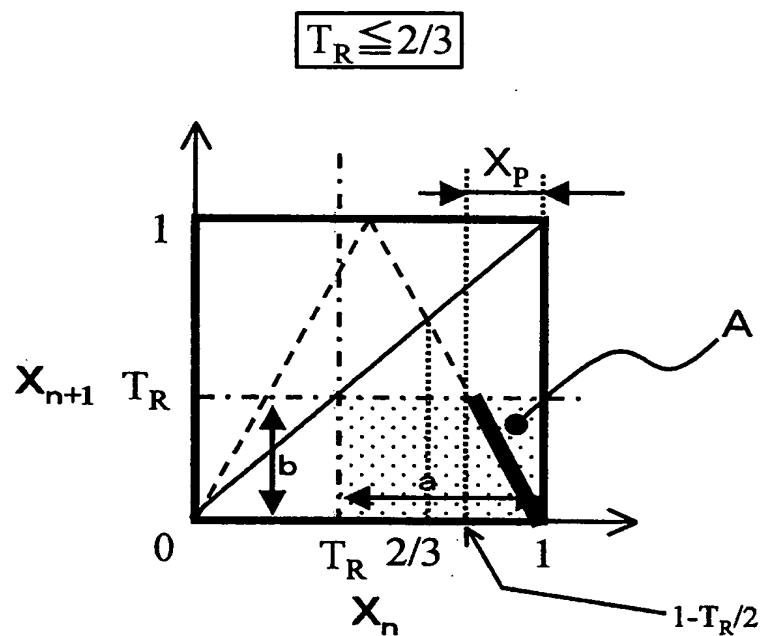
第 10 図



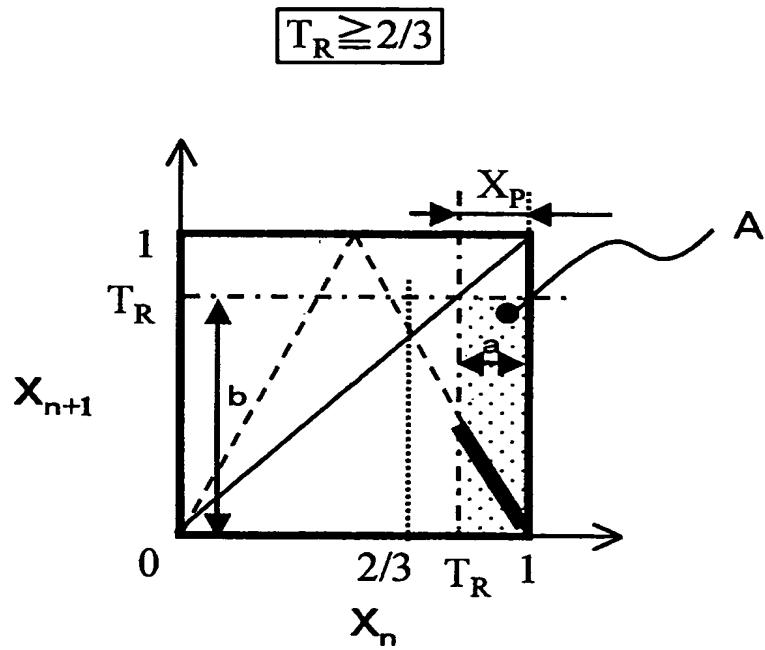
第 11 図



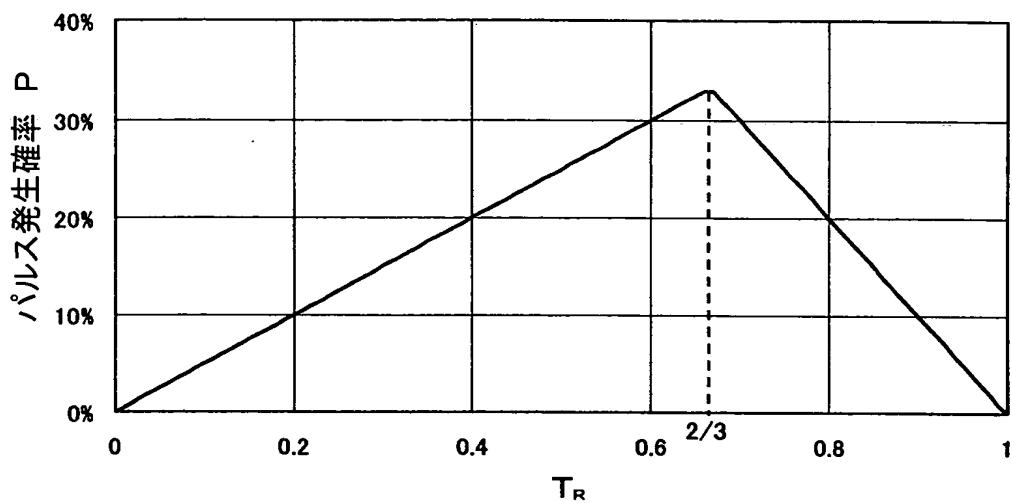
第12図A



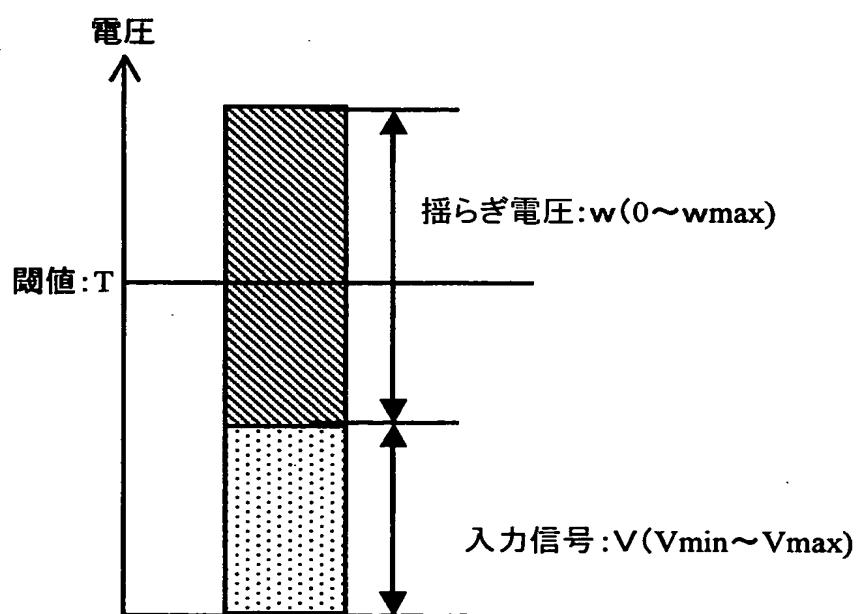
第12図B



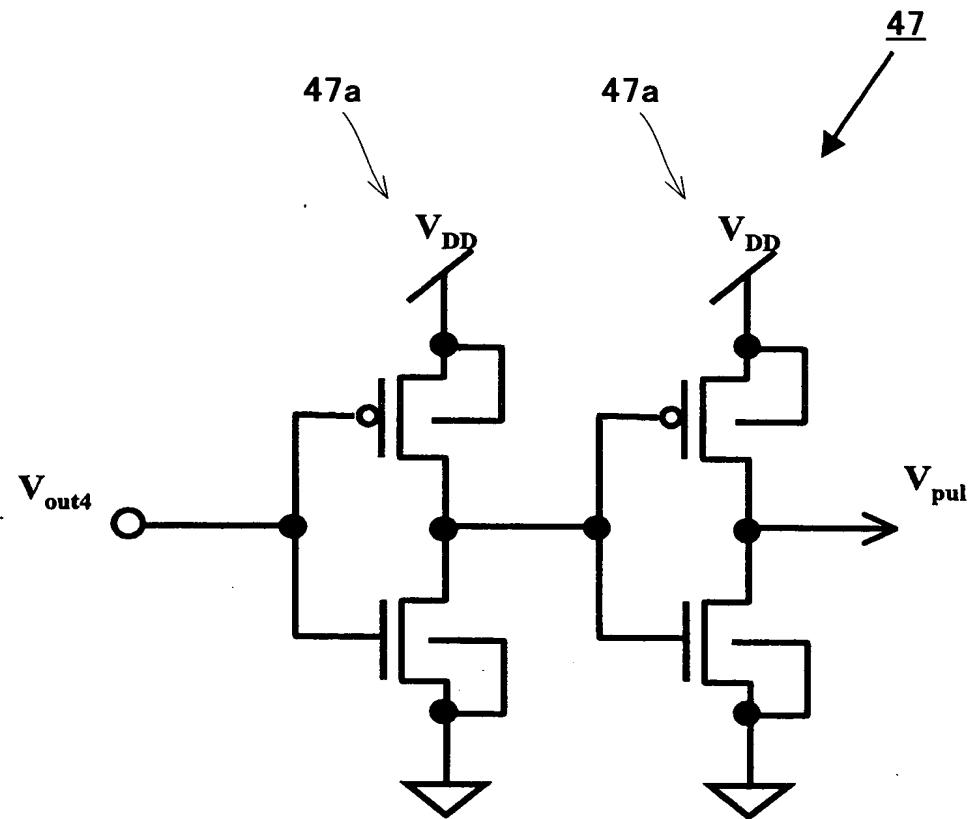
第 13 図



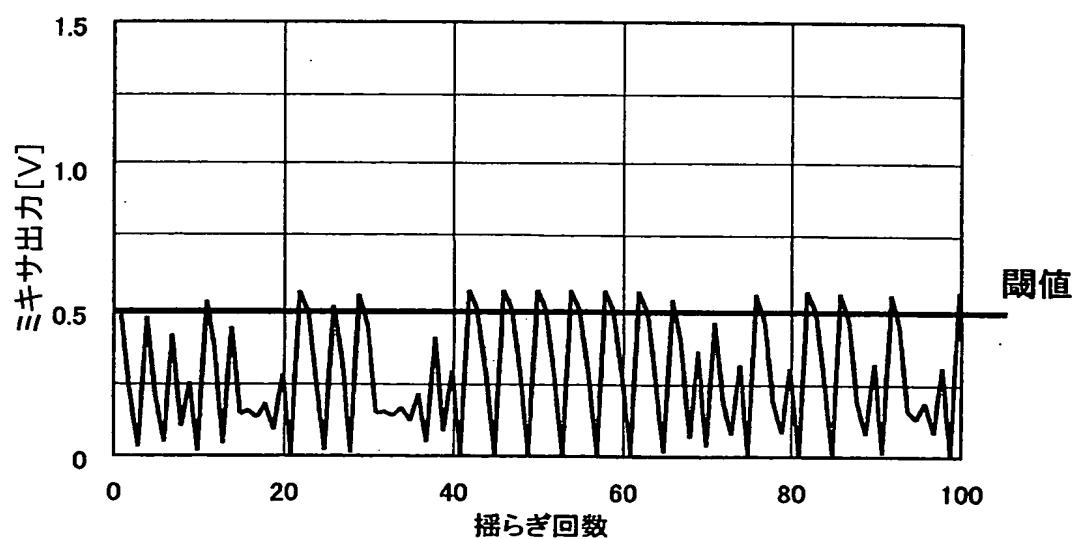
第 14 図



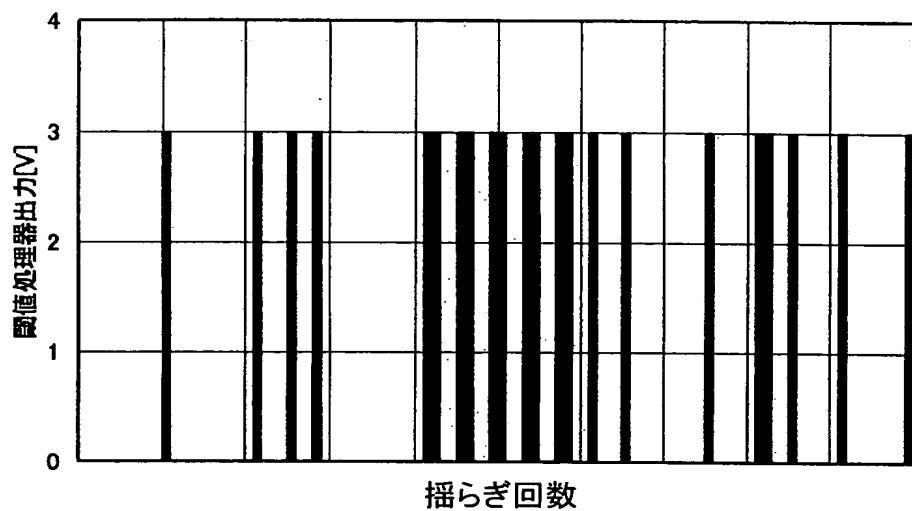
第 15 図



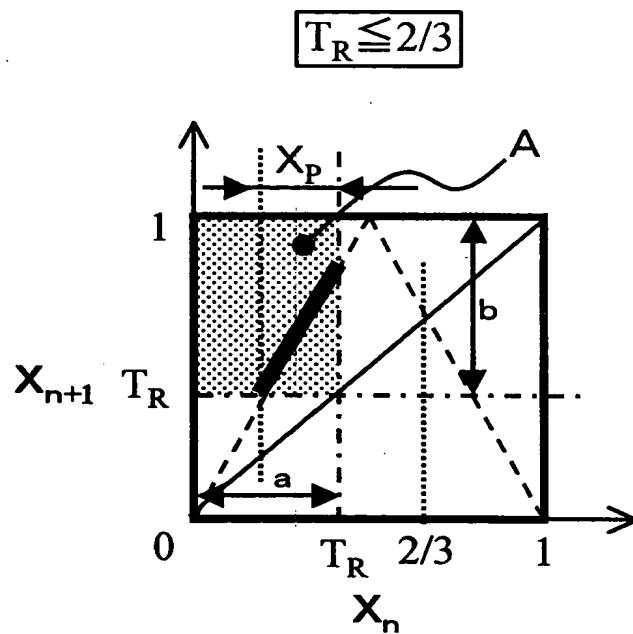
第 16 図



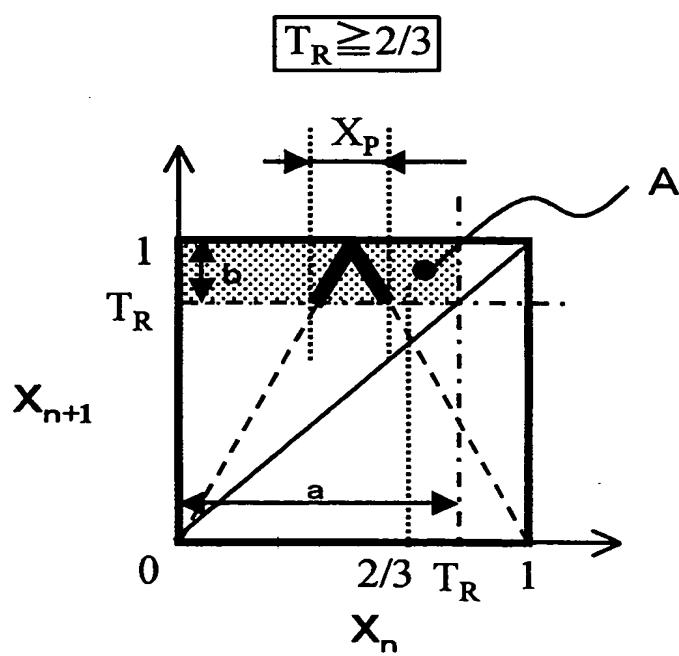
第 17 図



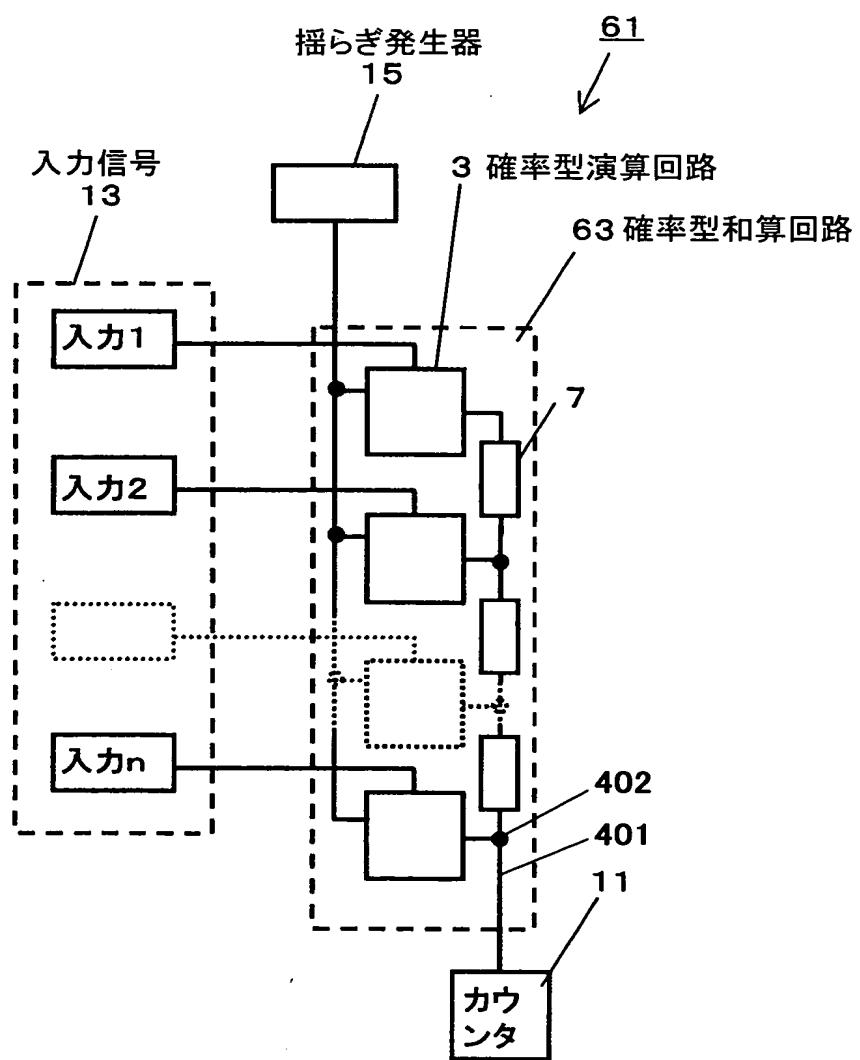
第18図A



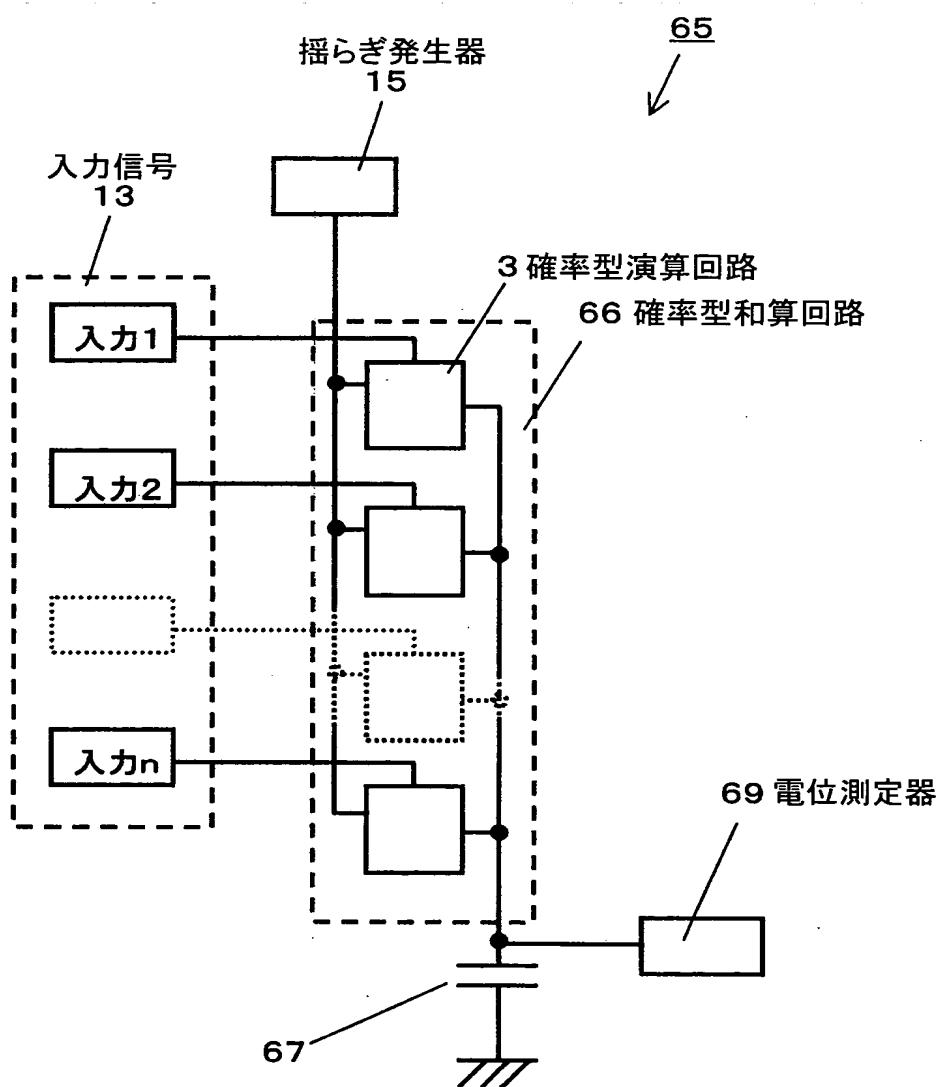
第18図B



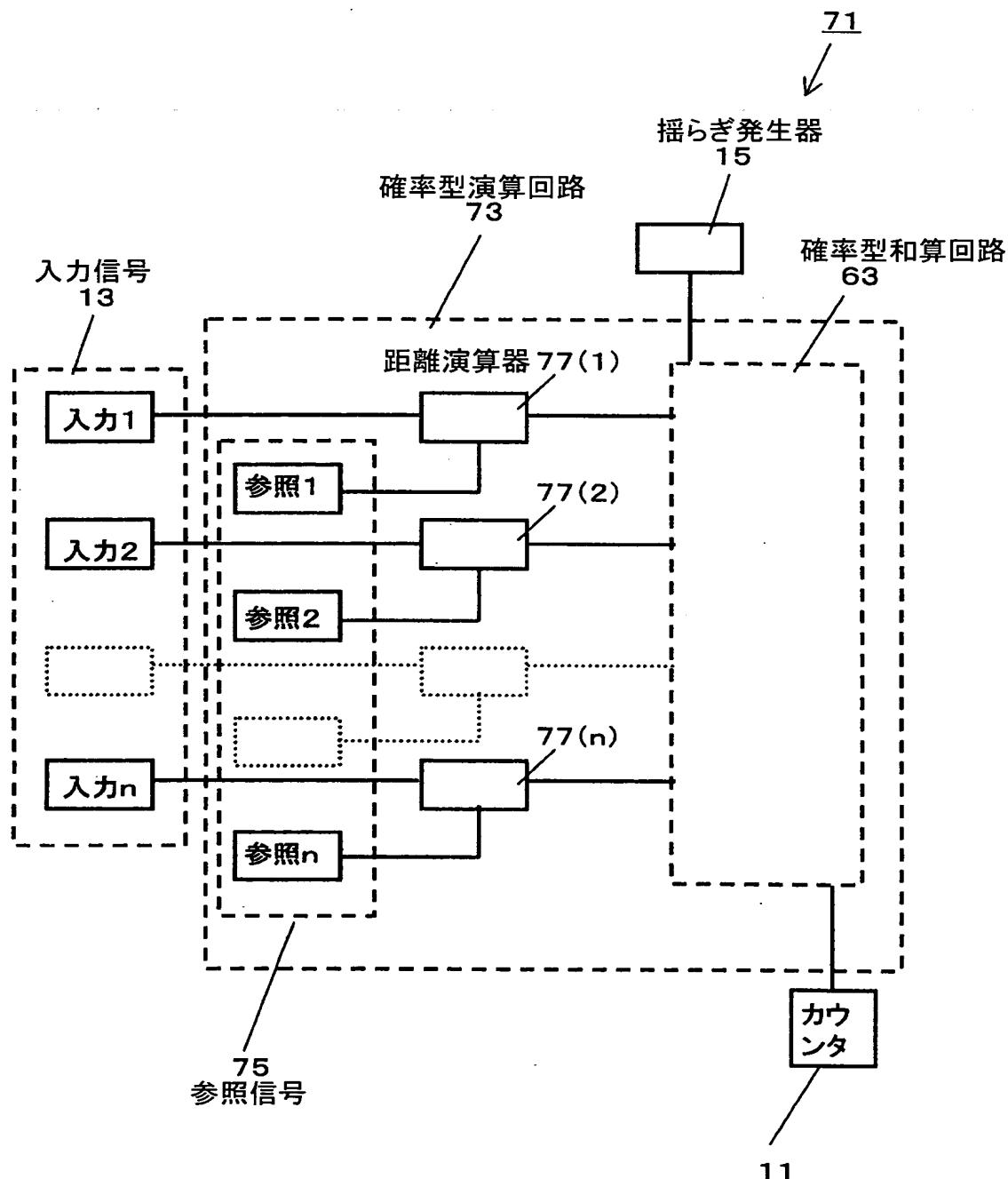
第19図



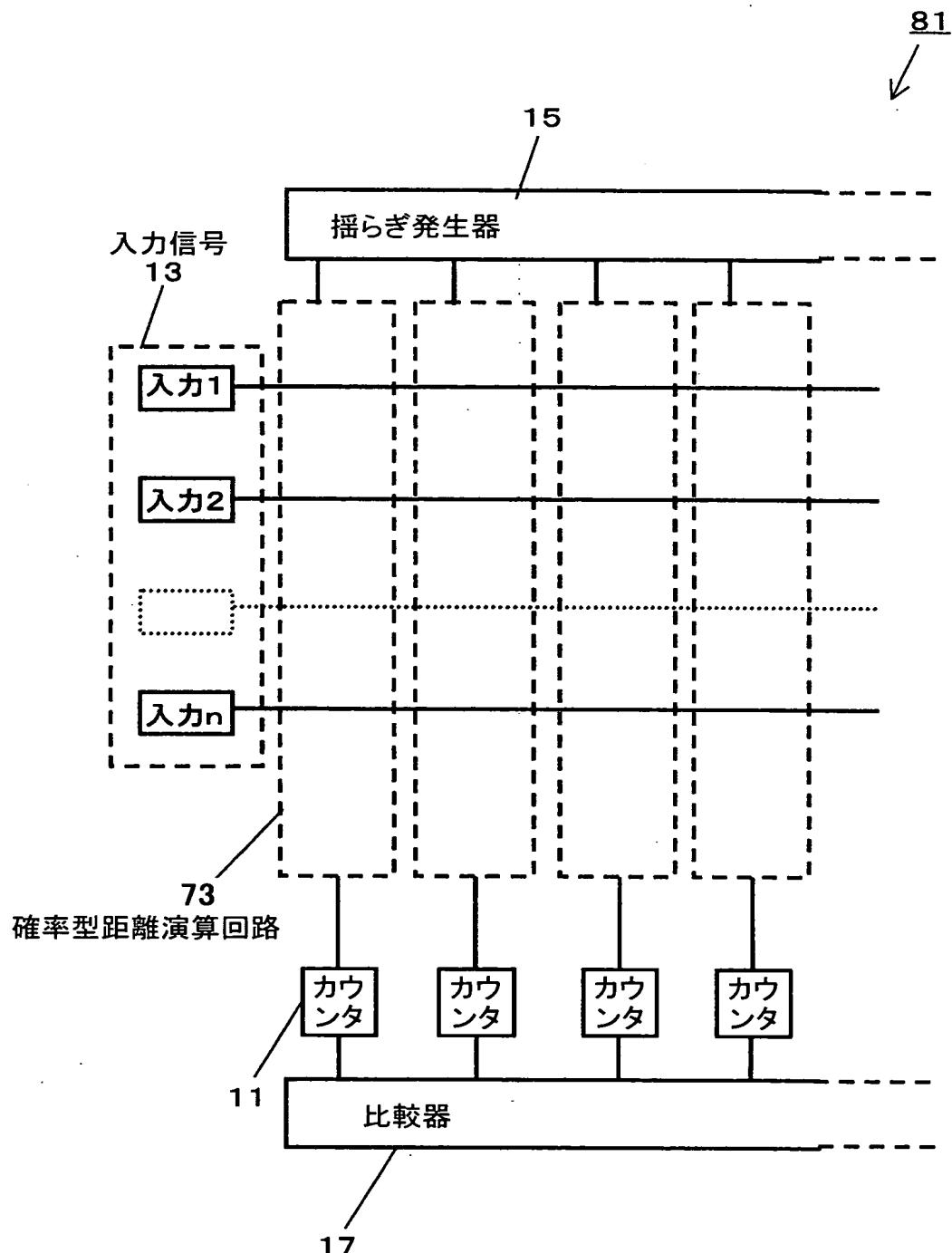
第 20 図



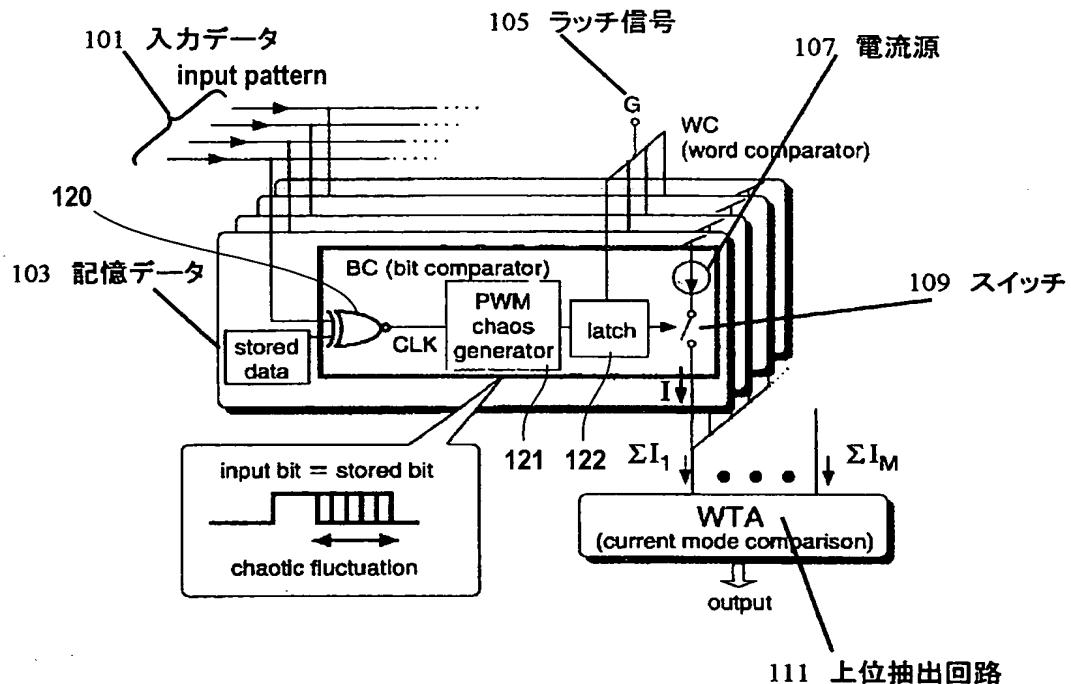
第 21 図



第22図



第23図(従来技術)



第24図(従来技術)

